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PATENT

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Box 1450, Alexandria, 📆 Date

Ayesha J. Shaikh

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 09/970,100

Confirmation No. : 2699

Applicants: Vishnu K. Agarwal and Scott G. Meikle

Filed : October 2, 2001 Attorney Docket No.: 500453.04

Customer No. Art Unit : 1762

: 27,076

Examiner: William P. Fletcher, III

Title

: POLISHING PADS AND PLANARIZING MACHINES FOR MECHANICAL OR

CHEMICAL-MECHANICAL PLANARIZATION OF MICROELECTRONIC-DEVICE SUBSTRATE ASSEMBLIES, AND METHODS FOR MAKING AND USING SUCH

PADS AND MACHINES

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE UNDER 37 C.F.R. § 1.111

Sir:

Applicants acknowledge receipt of the Office Action dated August 2, 2004, and herewith petition the Commissioner for Patents under 37 C.F.R. § 1.136(a)(3) for a one-month extension of time for filing this response from November 2, 2004, to December 2, 2004. Submitted herewith is a check in the amount of \$110 to cover the cost of the extension. Any deficiency or overpayment should be charged or credited to Deposit Account No. 50-1266.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

12/08/2004 HALI11

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